

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT		ATTY. DOCKET NO.: 06205.0007	APPLICATION NO. 09/026,336
		APPLICANT: Samsung Aerospace Industries, Ltd. M. Tanaka et al.	
		FILING DATE: February 19, 1998	GROUP : 2612

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
	AA1						
	AB1						
	AC1						
	AD1						
	AE1						
	AF1						
	AG1						
	AH1						
	AI1						
	AJ1						
	AK1						

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION
N.V	AL1	JP 6-133081	May 13, 1994	Japan	H04M	11/00	NO
N.V	AM1	JP 6-268582	Sept. 22, 1994	Japan	H04B	7/26	NO
	AN1						Yes No
	AO1						Yes No
	AP1						Yes No

OTHER (Including Author, Title, Date, Pertinent Pages, etc.)

	AR	1	
	AS	1	
	AT	1	

EXAMINER	Ngoc - Yen Vu		DATE CONSIDERED	11/25/02

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LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

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Applicant:
Masahide TANAKA, et al.

Filing Date:
February 19, 1998

Group:
2722

2612

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINERS INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROP.)
N. V. N. V.	5,479,206 5,584,070	12/26/95 12/10/96	Ueno, et al. Harris, et al.	<u> </u>	<u> </u>	RECEIVED JUL 18 2002 Technology Center 2600

FOREIGN PATENT DOCUMENTS

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER

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